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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 3723

re the Application of: Toshihiko AKAHORI et al.

Examiner: Anthony Ojini

Filed: January 20, 2004

Serial No.: 10/759,163

Confirmation No.: 6643

For: CMP ABRASIVE, LIQUID ADDITIVE FOR CMP ABRASIVE AND

METHOD FOR POLISHING SUBSTRATE

Attorney Docket Number: 010777A
Customer Number: 38834

## <u>PETITION FOR EXTENSION OF TIME</u>

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

November 18, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated May 18, 2004 for three month(s) from August 18, 2004 to November 18, 2004.

Attached please find a check in the amount of \$980.00 to cover the cost of the extension. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

Westerman, Hattori, Daniels & Adrian, LLP

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